Fiber Deflection Probe for Small Hole Metrology

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Abstract

This paper presents the development of a new probing method for Coordinate Measuring Machines (CMM) to inspect the diameter and form of small holes. The technique, referred to as Fiber Deflection Probing (FDP), can be used for holes of approximately 100 μm nominal diameter. The expanded uncertainty obtained using this method is 0.07 μm (k = 2) on diameter. The probing system consists of a transversely illuminated fiber (with a ball mounted on the end) whose shadows are imaged using a camera. We can infer the deflection of the probe from the motion of the image seen by the camera, and we infer the position of the measured surface by adding the fiber deflection along x and y directions to the machine scale readings. The advantage of this technique is the large aspect ratio attainable (5mm deep for a 100 μm diameter hole). Also, by utilizing the fiber as a cylindrical lens, we obtain sharp crisp images of the fiber position, thus enabling high resolution for measured probe deflection. Another potential advantage of the probe is that it exerts an exceptionally low force (ranging from a few micronewtons down to hundreds of nanonewtons). Furthermore, the probe is relatively robust, capable of surviving more than 1 mm over-travel, and the probe should be inexpensive to replace if it is broken. In this paper, we describe the measurement principle and provide an analysis of the imaging process. Subsequently we discuss data obtained from characterization and validation experiments. Finally we demonstrate the utility of this technique for small hole metrology by measuring the internal geometry of a 129 μm diameter fiber ferrule and conclude with an uncertainty budget.

Keywords: Coordinate Metrology, Small Hole, Microfeature Metrology, Fiber Probe

1. Introduction

Measurement of diameter and form of small holes is of great importance in applications such as fuel injector nozzles, fiber optic ferrules, wire drawing dies, holes in printed circuit boards and medical apparatus such as syringes etc. Holes with large aspect ratios (depth/diameter) cannot readily be inspected by microscopes and require development of special sensors. The Moore M48 [1] Coordinate Measuring Machine (CMM) with a 0.3 mm diameter probe has been used at the National Institute of Standards and Technology (NIST). The relatively large contact forces in these probing systems and stiffness issues with thinner styli are primary limitations in measuring smaller features. While traditional probe-stylus combinations for the CMM cannot be used for smaller holes because of this limitation, the literature shows a variety of novel probes with thinner styli that have been constructed and mounted on a CMM. In such cases, the probe is mounted on the ram of

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the machine with the part on the table or vice versa. The CMM is used as a fine positioning system with stylus deflection on contact detected by the new probe. Zhang and Yang [2] and later Yang et al [3] report a probe for the measurement of holes of diameter 200 μm with an accuracy of approximately 1 μm. The probe is modeled as an elastic body whose deflections are sensed using capacitance sensors. Masuzawa et al [4] report a vibroscanning method for measuring smaller holes. This technology uses a vibrating micro probe that contacts an electrically conducting surface. Upon contact, the circuit closes, thus sending out a signal. The signal is intermittent as the probe is vibrating. The duration of contact with the surface in relation to the time for one amplitude of probe vibration provides an index of proximity of the probe to the surface. Masuzawa et al [4] refined this technique using a twin probe to measure non-conducting surfaces as well. The vibroscanning technology is capable of measuring holes of approximately 125 μm diameter with an accuracy of 0.5 μm. In a related development, Lebrasseur et al [6] report on two other probing techniques. The first uses a piezoresistive cantilever as the probe while the other method uses stress induced shift in resonant frequency as the probing mechanism. In another novel development, Takaya et al [7] and Hashimoto et al [8] report on a probing technique based on optically trapping a small particle. In this technique, a particle trapped optically at a fiber tip is used as a probe. Theoretical formulation and preliminary analysis only have been reported in this area. Physikalisch-Technische Bundesanstalt (PTB) has recently reported on the development of a fiber probing technique [9] with sub-micrometer uncertainties to measure holes of approximately 50 μm diameter. A thin fiber (15 μm diameter) with a ball (25 μm diameter) on the end is used as the probe. Light enters through the fiber and is incident on the ball. The back scattered light is imaged using a Charge Coupled Device (CCD) camera. The clear advantage of this technique is that the position of the ball is directly observed, thus requiring minimal contact forces and eliminating any sensitivity loss. Another recent development is the use of MEMs based technologies for dimensional measurement of micro features. Brand et al [10] developed a micro probe mounted on a thin wafer whose deflections are detected by piezoresistors embedded in the wafer. Haitjema et al [11, 12] report on the development of new probes that use strain gages embedded in tiny flexures that support the probe. These probes have nanometer resolutions and a claimed uncertainty on the order of 0.1 μm (probe nonlinearity is on the order of 10 nm).

There is also literature on small hole measurement capabilities by National Measurement Institutes (NMI) around the world. In a recent international comparison conducted by PTB [13], six European national metrology institutes measured ring gages between 0.1 mm and 1 mm diameter. The expanded uncertainty (k = 2) on the smallest hole (100 μm nominal diameter) is between 1 μm and 3.8 μm. Many of the techniques reported in the literature address the challenge of measuring small holes with large aspect ratios but have large uncertainties. MEMS based probes with strain gages are expected to have superior performance as demonstrated by [11, 12], but are expensive to manufacture. In this paper, a new probing method is proposed that addresses both the aspect ratio and uncertainty issue in small hole metrology. We refer to
this method as Fiber Deflection Probing (FDP). The technique differs from the method described in [9] (developed at PTB) in that we monitor the position of the fiber stem, a few millimeters from the ball, in two orthogonal directions, instead of observing the ball directly. By illuminating the probe stem in a plane perpendicular to the fiber, we are able to travel deep into the hole (a depth of approximately 5 mm into a 100 μm hole), without being limited by diffraction effects in the case of back-scattered light from the ball. Also, by utilizing the fiber stem as a cylindrical lens, we are able to obtain a sharp image of the fiber’s position to enhance edge detection. Our technique is simple, inexpensive to develop and yields an expanded uncertainty of 0.07 μm (k = 2) for holes of diameter 100 μm.

Some of the basic ideas behind inferring the fiber probe position by observing the fiber stem have been described previously in [14,15] and also in a patent held by Werth Messtechnik GmbH [16]. The use of the stem as a cylindrical lens to focus light for clear edge determination was first described in [17]. In subsequent sections, we discuss the principle of this technique, construction details, characterization and validation results. Finally, we demonstrate the utility of this technique by discussing measurement results from a 129 μm fiber ferrule hole and conclude with an uncertainty budget.

2. Fiber Deflection Measurement

2.1 Principle

A thin glass fiber, cantilevered at one end and with a ball mounted on the other, serves as the probe. A small segment of this fiber is illuminated by a laser diode as shown in Fig. 1 a short distance below the ball. The shadow of the fiber is magnified and imaged using a camera. When the probe contacts a surface, it is deflected by a small amount. The magnitude of this deflection is determined by recording the position of the fiber in the free state and in the deflected state. This deflection is then corrected from final machine coordinates to obtain the position of the surface.

2.2 Optical Setup

The optical setup is illustrated in Fig. 2. Collimated beams from two orthogonal directions illuminate the fiber approximately 5 mm below the ball. The shadows of the stem are magnified using 7X objectives (4) placed in front of the fiber. The resulting
images are further magnified using 5X eyepieces (6) and imaged using a CCD camera. The mirror (7) in front of the camera (8) extends half way across the pixel array, so that light from one axis illuminates half of the array and light from the second axis falls on the other half of the array.

The use of one camera for imaging the fiber from both directions places a constraint on the amount of magnification achievable. Each half of the pixel array should not only be able to image the full width of the stem in its null position, but also when the probe deflects by approximately 25 μm in each direction. Monitoring the outer boundaries of the shadow is not feasible under this constraint. We instead determine the fiber position using a thin band of light visible on the center of the fiber shadow in the image plane. The formation of this band is discussed in the next section.

![Fig. 2 Optical setup for fiber deflection measurement (a) Photo and (b) Schematic](image)

**2.3 Imaging Analysis**

Fig. 3 shows typical distances of the lenses and image plane, along with a screen shot of the fiber stem’s shadow at the image plane. From geometrical optics, the stem undergoes a magnification of 35 and this is also verified experimentally. Also seen in Fig. 3 is a thin band of light in the middle of the shadow of the stem. This band is produced by refraction of the source at the leading edge of the glass fiber and again at the trailing edge, as shown in Fig. 3. For purposes of this analysis, it is assumed that a collimated beam is incident on the fiber. Consider a ray at a distance $X$ from the optical axis. The normal at the point of contact with the fiber makes an angle $\alpha_1$ as shown in Fig. 3. Then, from the law of refraction,

$$\beta_1 = \sin^{-1}(\sin(\alpha_1) / \mu)$$

(1)

where $\mu$ is the refractive index of glass. The refracted beam strikes the fiber again at the right edge and undergoes a second refraction. Because triangle OAB is an isosceles triangle and from the law of refraction,

$$\beta_2 = \sin^{-1}(\mu \sin(\beta_1))$$

(2)

$$\alpha_2 = 2\beta_1 - \alpha_1$$

(3)

The refracted ray finally makes an angle $\phi$ with the axis, where $\phi$ is given by
The position where the ray strikes the axis, measured from the fiber center, is computed using Eq. 5 below:

\[ Y = \frac{R \sin(\alpha_z)}{\tan(\beta_z - \alpha_z)} + R \cos(\alpha_z) \]  

From Eq. 5, an incident ray close to the axis (say, \(X = 10 \mu m\)) meets the axis farther away after double refraction and at smaller angles than another ray farther away (say, \(X = 20 \mu m\)). As a consequence of this aberration (which is the two-dimensional analog of the aberrations of a small ball lens in three dimensions), the light emerging from the 50 \(\mu m\) fiber is focused to a minimum size on the order of 8 \(\mu m\) width and then diverges. However, if we restrict our attention to rays that can enter our 0.2 N.A. objective lens, then ray tracing shows that the minimum line width is reduced from 8 \(\mu m\) to 90 nm. In the geometric optics limit, the width of the image on our camera can then be found by multiplying the 90 nm line width following the fiber by the lateral magnification of the microscope. (Note: we have verified through ray tracing that multiplying by the magnification gives the correct answer for our microscope.) This predicts a width of 3.1 \(\mu m\) for the bright line on the pixel array.

The actual smallest width of the bright band on the CCD array, as observed experimentally, is approximately 125 \(\mu m\). While ray tracing indicates that it should be possible to tune the objective position to obtain a width of 3.1 \(\mu m\) at the image plane, diffraction effects dominate in our system. The diameter of the Airy disk for N.A.= 0.2 and red light illumination is about 3.6 \(\mu m\). This value is much larger than 90 nm, which is the smallest width of the band we are trying to image. Therefore, diffraction will dominate over the effects of aberrations for our system with N.A=0.2. At a magnification of 35, diffraction should limit the width of the image to about 125 \(\mu m\), equivalent to 15 pixels, which is roughly what we see experimentally. The diffraction limit is here much larger than the pixel size, suggesting that we might be able to reduce the magnification without degrading performance. However, we have thus far not been successful in doing this.

When we image only the bright band at the center of the fiber, the diffraction from the edges of the fiber is not important because it does not overlap the image of the central bright band. If we image the entire fiber, diffraction patterns are indeed seen along the edges, and this might limit our ability to define the position of the fiber if we were to use the outside edge of the full fiber for measurement. However, our only requirement is to reproducibly observe changes in the fiber position, which are not affected by a constant diffraction pattern. Furthermore, we are somewhat immune to details of the imaging of the fiber edges if we determine the position of the center line of the fiber by averaging the positions of the two edges, so that any diffraction-induced shift in the apparent position of one edge is cancelled by a similar shift of the position of the opposite edge. More importantly, averaging two edges provides some immunity to variations in illumination and in defocus. (This is true whether we are using the entire fiber or the central bright band.)
2.4 Image Processing

The shadows of the fiber stem, as projected onto the camera, appear as a dark region with a bright band down the center. When working in two dimensions, two bands are seen on the camera, as shown in Fig. 4 (a). Our normal method of conditioning the image involves three steps. (1) We determine a threshold value related to the intensity distribution of the image. (2) Based on this threshold, we convert the image from 8-bit gray scale to a binary bright/dark image. (3) We then apply a particle-removal function to suppress the influence of any dirt particles. The resulting image is shown in Fig. 4 (b). The second step, converting the image from a graduated gray scale to bright/dark, seems to be helpful for successful particle removal in the third step. There is some danger that the second step will degrade performance due to loss of subpixel information, but the loss is minimal if the fiber is angled slightly so that the image does not align exactly with a column of pixels. We have found that analysis of subpixel information can improve performance under special circumstances but is not helpful for our normal measurements.

After conditioning the image, the leading and trailing edge coordinates for both bright bands are determined for each horizontal pixel row. This information is used (through least squares fitting and averaging) to determine the center pixel of each of the bands at the center row. The center pixel coordinates so obtained, are monitored before and after fiber deflection to obtain the magnitude of CMM over travel.
2.5 Imaging Uncertainty

While an uncertainty budget for diameter and radial out-of-roundness (OOR) measurements is presented later on, we discuss the uncertainty in determining the fiber center due to imaging to understand the performance of the system. The system has an optical magnification of approximately 35. The width of each pixel in the camera is 8500 nm. Thus, single-pixel resolution is \(\frac{8500}{35} \approx 243\) nm when sub-pixel interpolation is not employed. Therefore, the center can lie within ±122 nm and ±122 nm with equal probability. Assuming a rectangular distribution, the standard uncertainty is \(\frac{122}{\sqrt{3}} \approx 70\) nm. This is the uncertainty in determining the center using just one row of pixels. We average over 400 rows to reduce this uncertainty. In the absence of noise, the reduction in uncertainty due to averaging is a complex function of the angle of the fiber relative to the pixel array. If the fiber is tilted relative to the pixel array so that it crosses more than three pixels in the horizontal direction, then the error due to pixel resolution is reduced below ±0.04 pixels (±10 nm). Assuming a rectangular distribution of errors, this ±10 nm range of possible errors corresponds to a standard uncertainty of 6 nm. For some angles the uncertainty might be considerably smaller, but as long as the angle is large enough that at least three horizontal pixels are crossed, the uncertainty will not exceed this value. Also, as a consequence of the fact that we measure both the left and right edge of the band, the uncertainty will be reduced to a value on the order of \(\frac{6}{\sqrt{2}}\) nm ≈ 4 nm. Thus we might hope to see roughly a 4 nm uncertainty in detecting the position of the probe in space under ideal conditions. We have carried out measurements that indicate that this small uncertainty for the imaging system is probably attainable, but under realistic conditions our uncertainties are much larger due to other factors, with the imaging uncertainty contributing negligibly to the overall uncertainty budget. Although the 4 nm uncertainty might be improved further by sophisticated sub-pixel interpolation, there is no practical advantage to doing so.
3. Fiber Probe

3.1 Probe Manufacture

The early experiments used a 30 mm long, 125 μm diameter glass fiber with a 155 μm diameter ball on the end. The later experiments used a 20 mm long, 50 μm diameter glass fiber with a 75 μm diameter ball on the end. Early versions of the probe are manufactured by melting a ball at the end of the fiber using a blowtorch. This method does not adequately center the ball on the fiber. The second version with thin glass fibers (50 μm diameter, 20 mm long) is made in-house by gluing a microsphere to the end of a fiber.

The method developed here uses the existing optical setup to also manufacture the probes but with one small modification. Because it is necessary to image the entire ball and the fiber stem from two directions, the eyepieces are removed to reduce the magnification. The microsphere is placed on a small flat shiny surface and its images along two perpendicular directions are obtained on the monitor. The fiber is brought down from the top using a 3-axis stage. The fiber is dipped in epoxy, with the excess glue removed prior to bonding with the microsphere. Fig. 5 shows images of a fiber before and after bonding to a microsphere. In each of the figures, (a) and (b), two orthogonal views of the same fiber-microsphere are shown.

![Fig. 5 Orthogonal views of the fiber and microsphere (a) Before bonding (b) After bonding (Stem φ50 μm and ball φ75 μm)](image)

3.2 Probe contact force and resonant frequency

The contact force for a 125 μm diameter, 30 mm long fiber stem made of glass (E = 80 GPa) assuming typical deflections of 20 μm is 2 μN. For a 20 mm long, 50 μm diameter stem, the contact force is only 0.2 μN. When the probe is not in contact with a surface, the resonant frequency for a 125 μm diameter probe with a 155 μm ball is 695 Hz (4366 rad/sec) while it is 625 Hz (3928 rad/sec) for a 50 μm probe with a 75 μm ball on the end. A high resonant frequency is desirable, although we have not seen degradation in performance at lower resonant frequencies. The extremely small contact forces prevent part damage during measurement of microstructures and also eliminate the need for any deformation corrections. The very low effective mass of the fiber probes (on the order of 24 μg) is also important, as this reduces inertial impact forces when the probe hits a surface.
4. 1D Characterization of the system

Before the system is mounted on a CMM for rigorous testing, 1D performance is evaluated using a piezo stage (Fig. 6). An arm is mounted on the piezo stage and is aligned parallel to one optical axis of the deflection system. A retro reflector is held at the end of this arm and a 5 mm steel ball is glued to the backside of the retro reflector. The ball serves the function of a test surface and is centered on the retro reflector to essentially measure at zero Abbe offset. The ball is brought in contact with the fiber, which is deflected by moving the piezo stage. The actual distance traveled by the stage is monitored using a laser interferometer. This setup is used for calibration (determining a scale factor that relates displacement of probe stem in pixels to displacement of the tip in micrometers) in one axis (active axis) and also to subsequently evaluate linearity in that axis.

![Fig. 6 Characterization setup in one axis](image)

![Fig. 7. Long-term linearity results in 1D (legend shows standard deviation for each run). The scale factor was determined earlier to be 0.2750 μm/pixel.](image)

Fig. 7 shows 12 runs where the apparent position of a surface is measured as a function of probe displacement. The data was acquired over a 40 min period. The data gives some indication as to the magnitude of the errors that can be expected to occur after calibration of the probe, including errors that might arise from random noise, nonlinearity, hysteresis, or variations in the calibration factor.
Each of the 12 runs consists of 11 data points taken at displacements ranging up to 15 μm. At each point, the probe reading, multiplied by the scale factor, is added to the interferometer reading to give the apparent position of the surface in contact with the probe. In the absence of errors, this value would be a constant independent of probe displacement. In the graph, we have subtracted a constant so that the reading should be zero for all points, and the deviations shown in the graph are thus the errors due to nonlinearity or non-repeatability of the data. We use the same probe calibration factor for all the runs. We have subtracted a different constant for each run so as to eliminate the effect of a drift in our test apparatus. (The test apparatus had much greater drift than was observed in actual measurements on the machine.)

For each run, we compute the standard deviation of the data points, and this is shown in Fig. 7. It is seen that one standard deviation is between 6 nm and 25 nm for each run in this test. From Fig. 7, it is seen that there are no clear systematic effects in the linearity plot. The deviations shown in the diagram do not repeat well from one run to the next, indicating that the deviations arise primarily from random noise. For the entire data set comprising all 12 runs, one standard deviation is 17 nm.

5. 2D Characterization of the system

After the system is mounted on the CMM, scale factors are first determined using a procedure similar to that described earlier. However, the CMM is used as the positioning stage instead of the piezo. Also, unlike in the 1D case where only one scale factor was determined, scale factors are determined in both axes. In fact, because the optical magnifications are not identical for both axes and the point of observation on the fiber is also slightly different, scale factors are expected to be slightly different for each axis. In order to obtain a more robust estimate, scale factors are determined in four principal directions (+x, -x, +y, -y) and pairs are averaged to obtain estimates for x and y.

After obtaining the scale factors, a quick experiment to determine repeatability is conducted. The CMM is moved along positive x to the same coordinate several times, bringing the probe repeatedly into contact with a surface. The standard uncertainty due to repeatability is approximately 35 nm. This includes the machine positioning repeatability term (≈ 25 nm) and any surface effects such as slip because the probe loses contact with the part before each run.

In order to assess the performance of the system in 2D, linearity tests are conducted on the CMM. A 3 mm ruby sphere is used as the test artifact for this study. The ball is brought in contact with the probe from positive x direction and the probe is deflected approximately 21 μm. On the return path, 5 linearity data points are collected at a spacing of 3 μm. This procedure is repeated for each of the other three principal directions and the cycle is repeated 5 times. The deviation from linearity along each direction is shown in Fig. 8. It is seen that one standard deviation out-of-linearity error is of the order of 20 nm to 50 nm. This is slightly larger than the results obtained from 1D tests; the marginally better performance in the piezo test bed is probably due to better
environmental control around the probe as the entire assembly can be shielded from air currents, a situation not feasible on the CMM. Also, a portion of the linearity error on the CMM can be attributed to the machine’s positioning repeatability (≈ 25 nm) itself.

6. Validation Measurements

In order to validate the probing system, three artifacts of known diameter and form are measured using the FDP. Prior to each of these measurements, the fiber probe tip diameter and the form of the probe tip are calibrated by using a 3 mm ruby sphere of known diameter and form. The diameter of the calibration ball is measured using interferometry at NIST with an expanded uncertainty of 0.01 μm (k = 2). Table 1 shows a comparison of diameters obtained using FDP and other techniques. The agreement in diameters is to within 60 nm, which is smaller than the uncertainty of the measurements itself.

<table>
<thead>
<tr>
<th>Artifact</th>
<th>Dia from other sources (μm)</th>
<th>Dia from FDP (μm)</th>
<th>Difference (μm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>5 mm Sphere 1</td>
<td>4999.98 (UMM¹) ± 0.09</td>
<td>4999.92 ± 0.07</td>
<td>0.06 ± 0.15</td>
</tr>
<tr>
<td>1 mm Hole</td>
<td>999.53 (M48 CMM²) ± 0.15</td>
<td>999.48 ± 0.07</td>
<td>0.05 ± 0.17</td>
</tr>
<tr>
<td>5 mm Sphere 2</td>
<td>5000.19 (UMM¹) ± 0.09</td>
<td>5000.15 ± 0.07</td>
<td>0.04 ± 0.15</td>
</tr>
</tbody>
</table>

¹UMM – Universal Measuring Machine at NIST. Two point diameters are measured at 10 locations and averaged. ²Moore M48 CMM at NIST is used to measure the hole. The number following the symbol ± is the expanded uncertainty (k = 2).

Fig. 9, 10 and 11 provide more information on each of these measurements. They show the form error of the fiber ball estimated during calibration, the residual form on the test artifact and diameter information.
The ‘5 mm sphere 1’ and ‘1 mm hole’ artifacts are measured using a larger fiber probe. The fiber probe ball diameter is calibrated before measuring each test artifact. The values obtained are 155.12 ± 0.05 μm and 155.09 ± 0.05 μm, well within the uncertainty of the measurement. The form errors on the fiber ball are shown in Fig 9 (a) and 10 (a). The third artifact ‘5 mm sphere 2’ is measured using a smaller fiber probe and its form error is noticeably different, as seen in Fig. 11 (a). Also, each of the measurements reported here, both calibration and test artifact measurement, is the average of many runs. Typical one standard deviation repeatability in diameter is of the order of 10 nm to 20 nm over 3 to 5 runs and these are also recorded in the figures.

**Probe calibration on 3 mm Ball:**
LS fit mean $\phi = 3155.91 \mu m$
1σ on $\phi$ over 5 runs = 0.02 μm
Reference $\phi = 3000.79 \pm 0.01 \mu m$
⇒ Fiber Probe Ball $\phi = 155.12 \pm 0.05 \mu m$

**Test Measurement on 5 mm Ball:**
LS fit mean $\phi = 5155.04 \mu m$
1σ over 5 runs = 0.02 μm
⇒ Test Sphere $\phi = 5155.04 - 155.12 = 4999.92 \mu m \pm 0.07 \mu m$
Test Sphere OOR = 0.11 μm*
$\phi$ from UMM = $4999.98 \pm 0.09 \mu m$

**Probe calibration on 3 mm Ball:**
LS fit mean $\phi = 3155.88 \mu m$
1σ on $\phi$ over 5 runs = 0.01 μm
Reference $\phi = 3000.79 \pm 0.01 \mu m$
⇒ Fiber Probe Ball $\phi = 155.09 \pm 0.05 \mu m$

**Test Measurement on Hole:**
LS fit mean $\phi = 844.38 \mu m$ 1σ over 5 runs = 0.02 μm
Hole $\phi = 999.48 \pm 0.07 \mu m$
Hole OOR = 0.21 μm*
$\phi$ from CMM = $999.53 \pm 0.09 \mu m$

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Figure 9 Measurements on ‘5 mm sphere 1’ artifact (a) Probe ball form error (b) Form error on 5mm ball [The number following ± is the expanded uncertainty (k = 2)], * OOR uncertainty not evaluated yet

Figure 10 Measurements on ‘1mm hole’ artifact (a) Probe ball form error (b) Form error on hole [The number following ± is the expanded uncertainty (k = 2)], * OOR uncertainty not evaluated yet
7. Small hole measurement

After validating the probing system using the different artifacts, we demonstrate the utility of the probe for small hole metrology by measuring the internal geometry of a ceramic fiber ferrule with a nominal diameter of 129 \( \mu \text{m} \). We discuss preliminary measurements and potential issues here.

The fiber ferrule hole is located by simply centering the fiber using the outer surface of the ferrule. Because the inner surface is concentric with the outer surface to within 2 \( \mu \text{m} \), location of the hole is relatively simple and does not require any special optics. The fiber is inserted 80 \( \mu \text{m} \) inside the hole and a measurement is made. The diameter obtained is 129.58 \( \mu \text{m} \) and the form error is 1.04 \( \mu \text{m} \) (radial OOR). This is shown in Fig. 12. These values are not yet verified using other techniques.

The FDP is subsequently used to measure the inside geometry of a different ferrule by measuring traces at multiple heights as shown in Fig. 13. The visible tilt in the axis is

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**Probe calibration on 3 mm Ball:**

- LS fit mean \( \phi = 3088.12 \mu \text{m} \)
- 1\( \sigma \) on \( \phi \) over 3 runs = 0.01 \( \mu \text{m} \)
- Reference \( \phi = 3000.79 \pm 0.01 \mu \text{m} \)

\( \Rightarrow \) Fiber Probe Ball \( \phi = 87.33 \pm 0.05 \mu \text{m} \)

**Test Measurement on 5 mm Ball:**

- LS fit mean \( \phi = 5087.48 \mu \text{m} \)
- 1\( \sigma \) over 3 runs = 0.02 \( \mu \text{m} \)
- Test Sphere \( \phi = 5000.15 \pm 0.07 \mu \text{m} \)
- Test Sphere OOR = 0.18 \( \mu \text{m} \)

\( \phi \) from UMM = 5000.19 \( \pm 0.09 \mu \text{m} \)

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**Figure 11** Measurements on ‘5 mm sphere 2’ artifact  
(a) Probe ball form error 
(b) Form error on 5mm ball 
[The number following \( \pm \) is the expanded uncertainty (\( k = 2 \))], * OOR uncertainty not evaluated yet

**Figure 12** (a) Probe form error (b) Form error on 129 \( \mu \text{m} \) fiber ferrule hole 
[The number following \( \pm \) is the expanded uncertainty (\( k = 2 \))], * OOR uncertainty not evaluated yet

The fiber ferrule hole is located by simply centering the fiber using the outer surface of the ferrule. Because the inner surface is concentric with the outer surface to within 2 \( \mu \text{m} \), location of the hole is relatively simple and does not require any special optics. The fiber is inserted 80 \( \mu \text{m} \) inside the hole and a measurement is made. The diameter obtained is 129.58 \( \mu \text{m} \) and the form error is 1.04 \( \mu \text{m} \) (radial OOR). This is shown in Fig. 12. These values are not yet verified using other techniques.
attributed to the misalignment of the hole with the machine’s axis. We have not created a
reference datum for this measurement and therefore rely on aligning the probe and the
hole with the machine’s axis. While misalignment of the hole’s axis will manifest itself
as tilt in the measured data, any misalignment in the probe’s stem will result in the probe
shanking at larger depths. There is evidence of this effect in Fig. 13 with profiles at larger
depths showing two outlier points, an effect not as evident in the profile near the mouth
of the hole (trace corresponding to \(Z = 30 \, \mu m\)). And finally, the data also indicates a
piece of dirt at a depth of 130 \(\mu m\) as shown in Fig. 13. Dirt appears to be a potential
problem with periodic cleaning of the part and the fiber ball necessary to obtain outlier
free data. The diameter values reported in Fig. 13 are computed on 14 sampling points,
omitting the 2 points that indicate stem shanking.

8. Uncertainty Analysis

In this section, we outline an uncertainty budget for diameter measurement using the
FDP. For this discussion, we consider measurements on a 100 \(\mu m\) ceramic ferrule. A 20
mm long, 50 \(\mu m\) diameter glass fiber with an 80 \(\mu m\) ball on the end is considered as the
probe. Probe ball diameter and radial form error calibration are performed using a 3 mm
ruby sphere. Table 2 lists sources that contribute to uncertainty in diameter of the test
artifact. From Table 2, the combined standard uncertainty is 34 nm on diameter of test
artifact. Thus, the expanded uncertainty is 0.07 \(\mu m\) (k = 2) on diameter. We present a
short overview of the sources of error here; more detailed discussion can be found in
[16].

A large contributor to the uncertainty in diameter is single point repeatability
(experimentally determined to be approximately 35 nm); this is primarily due to the
machine position repeatability (25 nm) and imaging uncertainty (4 nm). Thus, the
uncertainty in determining every coordinate in space is approximately 35 nm. From
Monte Carlo simulation (MCS) using Gaussian noise, this translates to 18 nm standard
uncertainty in best-fit diameter (using 16 sampling points). This term is counted twice,
one for the calibration artifact and again for the test artifact.
There is an error associated with determining the scale factor (in units of μm/pixel). This error will not influence diameter if the same scale factor value is used during calibration and subsequent test artifact measurement. This is true under the circumstance that the fiber deflects by the same nominal amount at all angular positions (sampling locations) of both the master ball and test artifact. In reality, the fiber will not deflect by identical amounts at all angular positions of any artifact because of centering and part form error. The contribution of this term is therefore listed in the table.

The contribution to diameter uncertainty from master ball diameter error is approximately 5 nm. The error in determining the master ball’s equatorial plane is assumed to be about ±1.5 μm, which results in a standard uncertainty of about 1 nm in diameter. Similarly, the tilt in the test hole’s axis is assumed to be ±0.5°, resulting in 1 nm standard uncertainty in diameter. Temperature effects are typically not significant for dimensional measurement of small objects. Assuming ±0.05°C fluctuation in temperature, the standard uncertainty in determining master ball diameter because of non-standard temperature is 1 nm.

The optical axes of the probe measurement system will not necessarily be perpendicular to each other. Also, the axes will not be aligned with the machine’s axes. The offset angles can be estimated by analyzing the data obtained from the 4 principal machine directions. We typically software correct axis misalignment based on such experimental data. Assuming an uncertainty of ±0.5° in determining the offset angles, the net effect is 1 nm standard uncertainty in diameter. If the test artifact and the calibration sphere are of approximately the same size, this effect is almost canceled out.

Experimentally, we have determined the standard uncertainty in diameter to be of the order of 20 nm. This repeatability samples the different error sources we have outlined in previous sections. It is however possible that there are other sources we have not sampled. To account for these, we itemize a 20 nm uncertainty in diameter in our budget.

9. Conclusions

This paper presents the development of a novel probing method for CMMs to measure the diameter and form of small holes. The technique is based on imaging of a thin glass fiber stem. Holes of approximately 100 μm diameter can be measured to depths of about 5 mm using this method. Measurements are made on three artifacts, and diameters obtained using FDP agree with other techniques to within 60 nm. Using the probe, we have measured the diameter and inner geometry of a 125 μm nominal diameter fiber optic ferrule. Uncertainty budgets have been developed and they indicate an expanded uncertainty of 0.07 μm (k = 2) on diameter for 100 μm nominal diameter holes. We are currently studying the extension of this technique for profile and 3D measurement.

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Table 2 Error sources contributing to uncertainty in diameter

<table>
<thead>
<tr>
<th>Error source</th>
<th>Description</th>
<th>Uncertainty (nm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>1 $u_{\text{cal}}$(Coordinates)</td>
<td>Uncertainty in probe ball diameter due to uncertainty in determining coordinates (X, Y) of probing points. This is primarily because of imaging uncertainty and machine repeatability.</td>
<td>18</td>
</tr>
<tr>
<td>2 $u$(Coordinates)</td>
<td>Same as 1, but on test artifact</td>
<td>18</td>
</tr>
<tr>
<td>2 $u$(SF)</td>
<td>Uncertainty in scale factor combined with centering error</td>
<td>1</td>
</tr>
<tr>
<td></td>
<td>Uncertainty in scale factor combined with unequal nominal deflections between calibration and master ball</td>
<td>7</td>
</tr>
<tr>
<td>2 $u_{\text{cal}}$(Height)</td>
<td>Error in determining the equatorial plane (Z height) on master ball</td>
<td>1</td>
</tr>
<tr>
<td>3 $u_{\text{cal}}$(Master)</td>
<td>Uncertainty in master ball diameter and form</td>
<td>5</td>
</tr>
<tr>
<td>4 $u_{\text{cal}}$(T)</td>
<td>Uncertainty in diameter due to nonstandard temperature. This affects calibration sphere diameter primarily because of larger nominal diameter. Test artifact diameter is much smaller and temperature effects are ignored.</td>
<td>1</td>
</tr>
<tr>
<td>6 $u$(Tilt)</td>
<td>Error in determining tilt angle on test artifact</td>
<td>1</td>
</tr>
<tr>
<td>7 $u$(AM)</td>
<td>Probe axis misalignment introduces an error in diameter, some of which cancels out when measuring the cal-ball and later the test artifact. Also, most of this error is software corrected. The residual error is tabulated here.</td>
<td>1</td>
</tr>
<tr>
<td>8 $u$(Other sources)</td>
<td>Contribution from machine positioning and other sources</td>
<td>20</td>
</tr>
</tbody>
</table>

Subscript $\text{cal}$ indicates calibration process

References

1. Commercial equipment and materials are identified in order to adequately specify certain procedures. In no case does such identification imply recommendation or endorsement by the National Institute of Standards and Technology, nor does it imply that the materials or equipment identified are necessarily the best available for the purpose.
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